

APR. 18. 2003 10:16AM

925371 3903

NO. 5562 P. 3

OFFICIAL

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al.

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: C. Brown

For : A Method To Repair Localized Amplitude  
Defects In A EUV Lithography Mask Blank

AMENDMENT

Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed December 18, 2002, please amend the  
above-referenced application as follows:

FAX RECEIVED  
APR 21 2003  
GROUP 1700